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Docket No.: 50090-275

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Hiroki SHINKAWATA

Serial No.: 09/766,846 ✓

Filed: January 23, 2001

: Customer Number: 20277

: Confirmation Number: 1557

: Group Art Unit: 2811

: Allowed: February 23, 2004

: Examiner: Hung K. Vu

For: SEMICONDUCTOR DEVICE WITH TRANSFER GATE HAVING GATE INSULATING FILM AND GATE ELECTRODE LAYER (AS AMENDED)

REQUEST FOR ACKNOWLEDGEMENT OF THE CITED ART

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

We are in receipt of the Notice of Allowance dated February 23, 2004.

In reviewing the file, it is noted that we have not received acknowledgement of the Information Disclosure Statement and cited art filed October 24, 2003. Enclosed are copies of the Information Disclosure Statement, PTO-1449 and stamped return postcard acknowledgement.

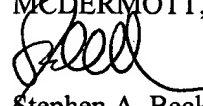
Applicant hereby respectfully requests that:

the appropriately acknowledged PTO-1449 be furnished to Applicant; and

the record be clarified to confirm that the cited art has been considered and made of record.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


Stephen A. Becker
Registration No. 26,527

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Date: April 8, 2004



Applicant: Hiroki SHINKAWATA Docket No. 50090-275
Title: SEMICONDUCTOR DEVICE WITH TRANSFER GATE HAVING GATE INSULATING FILM AND GATE ELECTRODE LAYER (AS AMENDED) Serial/Reg./Patent No. 09/766,846

Date Sent: 10/24/2003 ☒ Hand Carried ☐ Fax ☐ Electronic ☐ Cert. of Mailing ☐ Express Mail No. _____
☐ Transmittal Letter

New Patent App ☐ Utility ☐ Design ☐ Cont. ☐ CIP ☐ Div. ☐ PCT ☐ RCE ☐ Prov

☐ Other: _____

_____ pages of Specification
_____ pages of Claims
_____ pages of Abstract
_____ pages of Formal/Informal Drawings

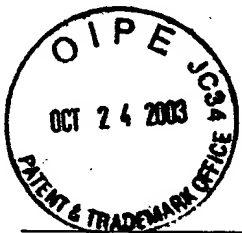
☐ Small Entity ☐ Large Entity
☐ Declaration/Power of Attorney
☐ Recordation of Assignment/Security Agreement
☒ Information Disclosure Statement

1 Form PTO 1449

1 copies of cited references

☐ Preliminary Amendment
☐ Response to Missing Parts Notice
☐ Resp. to Notice to Correct App. Papers
☐ Certified Copy of Priority Doc.
☐ Claim for Convention Priority
☐ Response/Amendment to Office Action of
☐ Request for _____ month Extension of Time

☐ Letter submitting _____ pages of drawings
☐ Req. for Approval of Drawing Amendments
☐ Req. for Oral Hearing
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THE PATENT AND TRADEMARK OFFICE DATE STAMPED HEREON IS ACKNOWLEDGEMENT THAT THE ITEMS, CHECKED ABOVE, WERE RECEIVED BY THE PTO ON THE DATE STAMPED.



Docket No.: 50090-275

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 20277
Hiroki SHINKAWATA : Confirmation Number: [conf_no]
Serial No.: 09/766,846 : Group Art Unit: 2811
Filed: January 23, 2001 : Examiner: Hung K. Vu
For: SEMICONDUCTOR DEVICE WITH TRANSFER GATE HAVING GATE
INSULATING FILM AND GATE ELECTRODE LAYER (AS AMENDED)

INFORMATION DISCLOSURE STATEMENT

Mail Stop Information Disclosure
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Information Disclosure Statement is being filed more than three months after the U.S. filing date and after the mailing date of a Final Rejection or Notice of Allowance, but before payment of the Issue Fee.

**REQUEST TO CONSIDER REFERENCES AFTER CLOSE OF PROSECUTION AND
BEFORE PAYMENT OF ISSUE FEE**

The undersigned hereby requests consideration and entry of this Information Disclosure Statement and accompanying references under 37 CFR 1.97(d).

Please charge the processing fee under 1.17(p) of \$180.00 to Deposit Account 500417.

CERTIFICATION PARAGRAPH

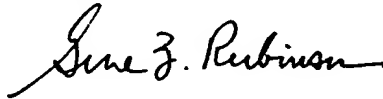
The undersigned certifies that, to the best of his knowledge, each item of information contained in this Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement as described in 37 CFR 1.97(e)(1).

Each non-English language reference was cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY



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Date: October 24, 2003

